In Place of FORM PTO-1449 (Modified) Serial No. Applicant: Ehrich, et. al. LIST OF PATENTS AND PUBLICATIONS FOR Filing Date: APPLICANT'S INFORMATION DISCLOSURE Group: **STATEMENT** Atty. Docket No. RSW920030290US1 **U. S. PATENT DOCUMENTS** Examiner Document Filing Date if <u>Initial</u> Number Date Name <u>Class</u> **Subclass Appropriate** KL AA 2002/0063735 May 30, 2002 Tamir et al. 345 745 KL AB 2002/0152237 Oct. 17, 2002 Cohen et al. 707 513 KL AC 2003/0065638 Apr. 3, 2002 Robert 707 1 KL AD 2002/0188694 Dec. 12, 2002 Yu 709 218 KL**AE** 2002/0065920 May 30, 2002 Siegel et al. 709 227 KL AF 2001/0051978 Dec. 13, 2001 Allen et al. 709 229 2002/0138331 KL AG Sep. 26, 2002 Hosea et al. 705 10 KL AH 2003/0074660 Apr. 17, 2003 McCormack et al. 725 2 KL ΑJ 2002/0054090 May 9, 2002 Silva et al. 345 747 KL AJ 2001/0016906 Aug. 23, 2001 Brebner 713 150 KLΑK 5,896,321 Apr. 20, 1999 Miller et al. 365 189.01 KLAL 5,977,964 Nov. 2, 1999 Williams et al. 345 327 **FOREIGN PATENT DOCUMENTS** Examiner Document Translation <u>Initial</u> Number Date Country Class <u>Subclass</u> Yes No AM EP1178410 Jun. 2, 2002 G06F17 Taiwan 30 Yes AO AP Examiner OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) <u>Initial</u> ΑO AR AS AT AU

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